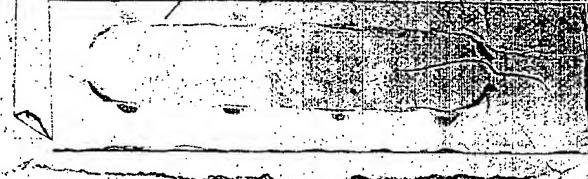




ISSUE CLASSIFICATION



**PATENT NUMBER**

**U.S. UTILITY Patent Application**

O.I.P.E.  Q.A. G.H. PATENT DATE

APPLICATION NO.	CONT/PRIOR	CLASS	SUBCLASS	ART UNIT	EXAMINER
09/740146	D	156	345	1763	Garcia Hessner

Applicants  
Ajay Kumar  
Jeffrey Chin  
Dragan Podlesnik

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Apparatus for performing self cleaning method of forming deep trenches in silicon substrates

PTO-2040  
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<input type="checkbox"/> The term of this patent, subsequent to <u>(date)</u> , has been disclaimed.		Sheets Drwngs (Date)	Figs. Drwngs (Date)	Print Fig. (Date)	Total Claims (Date)
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